



PATENT
Attorney Docket No.: SAM-0201
Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jong-hyon Ahn
Serial No.: 09/879,556
Filed: June 12, 2001
Title: METAL INTERCONNECT LAYER OF SEMICONDUCTOR DEVICE AND
METHOD FOR FORMING A METAL INTERCONNECT LAYER

Examiner: Hu, S.
Group Art Unit: 2811

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dec 17, 2003
Date

Lisa Sanders
Lisa Sanders

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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TECHNOLOGY CENTER 2800

PETITION FOR A TWO-MONTH EXTENSION OF TIME

Sir:

Applicant respectfully petitions for a two-month extension of the time allowed to respond to the Office Action mailed on August 13, 2003. This will serve to extend the time for responding to the Office Action from November 13, 2003 to January 13, 2004. The requisite fee of \$420.00 is enclosed.

The extension is being requested to maintain pendency of the present application to permit the filing of a divisional application based hereon.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: December 17, 2003
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